

Attorney Docket # 5300-23

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

John A ROUSE et al.

Serial No.: 09/994,563

Filed: November 27, 2001

For: Reduction Of Aberrations Produced By Wien  
Filter In A Scanning Electron Microscope And  
The Like

Examiner:

Group Art:

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Please also change the attorney docket number from to 5300-23. Thank you.

Respectfully submitted,  
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Dated: November 8, 2002